



Attorney Docket No. 0756-2330

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/894,125

Filed: June 29, 2001

For: CRYSTALLINE SEMICONDUCTOR
THIN FILM, METHOD OF
FABRICATING THE SAME,
SEMICONDUCTOR DEVICE, AND
METHOD OF FABRICATING THE
SAME

) Group Art Unit: 2823

) Examiner: B. Kebede

) CERTIFICATE OF MAILING

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) Adrian M. Stamp

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AFTER FINAL RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed November 7, 2005, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Accordingly, the Applicants respectfully submit that this response is being timely filed.

The Applicants note with appreciation the consideration of the Information Disclosure Statements filed on June 29, 2001; December 19, 2001; April 26, 2002; July 5, 2002; July 16, 2002; September 22, 2003 (corrected April 15, 2005); February 17, 2004; March 31, 2004; October 7, 2004; and September 2, 2005.

Claims 1-17, 19-30 and 47-58 are pending in the present application, of which claims 1-12, 19, 20, 47 and 48 are independent. For the reasons set forth in detail below, all claims are believed to be in condition for allowance. Favorable reconsideration is requested.

Please do not enter (Bn) 2/21/06